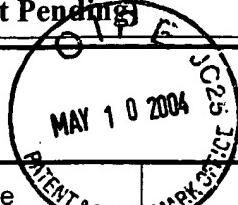


*Chen*

**TRANSMITTAL LETTER**  
**(General - Patent Pending)**

B  
Docket No.  
SEC.837

In Re Application Of: Jong-Woon OH et al.



Serial No.  
09/851,089

Filing Date  
05/09/2001

Examiner  
COLE, Laura C.

Group Art Unit  
1744

Title: **CLEANING APPARATUS FOR SEMICONDUCTOR WAFER**

**TO THE COMMISSIONER FOR PATENTS:**

Transmitted herewith is:

**Substitute Declaration**

in the above identified application.

- No additional fee is required.
- A check in the amount of \_\_\_\_\_ is attached.
- The Director is hereby authorized to charge and credit Deposit Account No. \_\_\_\_\_ as described below.
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Dated: 10 May 2004

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